

JUN 20 2005

501.41175X00/340101349US1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki NAKANO *et al.*  
Serial No.: 10/075,244  
Filed: 15 February 2002  
For: METHOD AND APPARATUS FOR PLASMA PROCESSING  
Group: 1762  
Examiner: M. Padgett  
Conf. No.: 7857

**AMENDMENT UNDER 37 CFR §1.114****Mail Stop RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

20 June 2005

Sir:

In addendum to the Notice of Appeal filed 18 April 2005, and in response to the Advisory Action mailed 29 April 2005 in connection with the above-identified application, the following amendments and remarks are respectfully submitted.

In accordance with 37 CFR §1.121 in the Final Rule effective 30 July 2003, and as revised in the Final Rule effective 21 October 2004, each section of amendment begins on a new page, and changes are shown by strike-through (or double brackets where appropriate) and underlining to indicate deletions and additions, respectively. A complete listing of all claims ever presented in the application is given with the current status of each claim, and only the text of all pending and withdrawn claims is presented in full, with those pending/withdrawn claims not being amended herein being presented in clean version.